

Enape

AE

Docket No. 1539.1003RE



**RESPONSE AND REQUEST FOR RECONSIDERATION
UNDER 37 C.F.R. §1.116**

**** EXPEDITED PROCEDURE ****

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Tomowaki Takahashi

Application No.: 09/665,184

Group Art Unit: 2873

Confirmation No.: 4343

Filed: September 15, 2000

Examiner: Evelyn A Lester

For: EXPOSURE APPARATUS HAVING CATADIOPTRIC PROJECTION OPTICAL SYSTEM

MAIL STOP AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This is responsive to the Final Office Action mailed February 18, 2004, having a shortened period for response set to expire on May 18, 2004.

The following remarks are respectfully submitted.